

## • Batteries

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[figure]

macro primary: Zinc-Air, Lithium, Alkaline

macro secondary: Lithium-Ion, NiMHd, NiCd

micro & flex

## Capacitors

electrolytic capacitors,

## • Energy harvesting:

### 1. micro thermoelectric generators (TEG)

① Seebeck effect

② in-plane configuration (IPC)

cross-plane configuration (CPC) [57]

③ thermoelectric efficiency:  $zT = \frac{\alpha^2 \sigma}{k} T$

### 2. mechanical vibration energy harvesters

① electromagnetic generator

② electrostatic generator

piezoelectric vibration energy harvesters

cantilever beams

### 3. radio frequency (RF) micro harvesters

① non-radiative RF energy transfer [84]

② radiative RF energy transfer (Friis equation)

HF power transfer (smart contact lens)

## • Human eye:

spherically-shaped organ, cornea, iris, pupil,  
crystalline lens, retina (rods, cones)

Artificial Iris:

- ① autonomic response to light
- ② depth of field (DOF)
- ③ pin hole effect

• Transistors:

$$\begin{aligned} \textcircled{1} I_B &= \frac{I_s}{\beta} e^{\frac{V_{BE}}{V_T}} & I_C &= \beta I_B & I_E &= (\beta + 1) I_B & I_B &\text{depends on } V_{BE} \\ I_s &= I_{s0} \left(1 + \frac{V_{CE}}{V_A}\right) & \beta &= \beta_0 \left(1 + \frac{V_{CE}}{V_A}\right) & I_C &\text{slightly depends on } V_{CE} & &\text{(early effect)} \\ \textcircled{2} \text{small signal model: } r_e &= \frac{V_T}{I_E} \end{aligned}$$

1. Current mirrors:

$$\textcircled{1} I_o = \frac{I_{ref}}{1 + \frac{1}{\beta}} \quad R_i \approx \frac{V_A}{I_{ref}} \quad [131]$$

$$\textcircled{2} \text{MOSFET current mirror: } I_o = I_{ref} \quad [132]$$

$$\textcircled{3} \text{with base current compensation: } I_o \approx \frac{I_{ref}}{1 + \frac{2}{\beta(1+\beta)}} \quad [133]$$

$$\textcircled{4} \text{Wilson mirror: } I_o = \frac{I_{ref}}{1 + \frac{2}{\beta(1+\beta)}} \quad R_i \approx \frac{\beta}{2} r_o(Q_3) \quad [134]$$

$$\textcircled{5} \text{Widlar mirror: } X I_o \quad R_E = \frac{V_T}{I_o} \ln\left(\frac{I_{ref}}{I_o}\right) \quad [135]$$

$$2. \text{operational transconductance amplifier: } i_o = \frac{(V_+ - V_-) I_{ABC}}{2V_T}$$

• Interfacing photodiodes:

transimpedance amplifier (TIA) [142]

$$\frac{V_o}{I_s} = \frac{-Z_F}{1 + \frac{1}{A\beta}} \triangleq Z_T$$

• LED:

① Buck converter [172]

② Boost converter [178]

③ capacitive voltage divider [181]

• Microdisplays:

1. Poly-Si [184]

2. DLP [188]

3. LCOS [208]

4. others: ① OLED on silicon ② X-Si ③ Pico projectors

• Radiometric & Photometric quantities:

① photopic response curve [216]

② lumens per watt

③ flux (light power):  $F_e (W)$ ,  $F_v (lm)$

④ flux density:  $E_e (W/m^2)$ ,  $E_v (lm/m^2 = lx)$   $E = \frac{dF_i}{dA}$

⑤ exitance:  $M_e (W/m^2)$ ,  $M_v (lm/m^2)$   $M = \frac{dF_o}{dA}$

⑥ intensity:  $I_e (W/sr)$ ,  $I_v (lm/sr = cd)$

⑦ luminance:  $L_e (W/m^2 sr)$ ,  $L_v (cd/m^2 = nit)$

Etendue:  $G = n^2 \int_{\Omega} \cos(\theta) dA d\omega (m^2 sr)$

• CCD:

1. characteristics:

① pixel count ② dynamic range ③ speed ④ physical size

2. architectures:

① full frame ② interline transfer ③ frame transfer

- Static characteristics:

static transfer function & range

accuracy & precision & resolution, systematic & random errors  
(noise)

(non-)linearity & hysteresis

- Dynamic characteristics:

bandwidth (zero, first, second order)

- Other characteristics:

input & output impedance, power supply, cross-influences,  
sensitivity distribution, reliability, efficiency

- Primary sensors:

temperature: bimetal

pressure: U-tube<sup>[85]</sup>, Bourdon-tube<sup>[86]</sup>, diaphragm<sup>[87]</sup>, capsule & bellows<sup>[89]</sup>

flow: orifice plate & diaphragm<sup>[93]</sup>, nozzle, Venturi-tube<sup>[94]</sup>

(Bernoulli's theorem:  $p + \rho gh + \frac{\rho v^2}{2} = \text{constant}$ )

- Signal conditioners:

1. amplitude: voltage & current

2. frequency: demodulation ( $f \rightarrow v + \text{ADC}$ )

3. linearization:

① non-linear sensor: using parallel resistor <sup>[112]</sup>

② current driven <sup>[117]</sup>

③ small-signal <sup>[118]</sup>

④ push-pull <sup>[120]</sup>

⑤ feedback [122]

⑥ afterwards numerically

• Signal transmission:

voltage & current transmission, frequency modulation  
digitizing, digital transmission

• Digital:

inertion switch (airbag trigger), tilt switch, reed switch

position - encoder: absolute, incremental/decremental,

Moiré encoder, photodetector

• EMF (self-generating)

1. thermocouple: Peltier & Thomson, thermopile

2. electret microphone

3. Piezo-electric sensor

4. Pyro-electric sensor

5. photovoltaic sensor

6. photodiode  $\left\{ \begin{array}{l} \text{photovoltaic} \\ \text{photoconductive} \end{array} \right.$

① noise  $\left\{ \begin{array}{l} \text{Johnson noise} \\ \text{Shot noise} \\ \text{Flicker noise} \end{array} \right.$

$\sim \sqrt{\text{bandwidth}}$   
 $\sim \sqrt{A_D}$

$$I_N = \sqrt{I_w^2 + I_s^2 + I_F^2}$$

② NEP (Noise Equivalent Power)

$$NEP = \frac{I_N(\text{dark})}{S_R} (W)$$

③ detectivity  $D = \frac{\sqrt{B}}{NEP} \left( \frac{\sqrt{Hz}}{W} \right)$

④ response speed  $T_R = \sqrt{T_{LC}^2 + T_{DIF}^2 + T_{RC}^2}$

## ① photodiode circuits [175]

### ◦ Resistive:

1. ① potentiometers    ② strain gauge    ③ push-pull

2. temperature sensors:

① RTD (compensation of wires)

② thermistor: NTC, PTC

3. photoconductor (LDR)

4. humidity sensor

### ◦ Capacitive:

1. plate separation

2. pressure & strain

3. level of liquid

4. permittivity

5. plate area: liquid level, position, rotation, tilt angle

6. interfacing capacitive sensors

7. capacitive accelerometer

### ◦ Inductive:

1. reluctance & self-inductance:  $N$ ,  $\mu$ ,  $L$   
(eddy current)

2. LVDT

### ◦ Other:

1. Hall sensor [237]

2. optical fiber sensor : intrinsic & extrinsic

3. fiber Bragg grating sensor

• Actuators:

electrostatic actuators :

interdigitated comb capacitor & parallel plate capacitor